Matiar M R Howlader

List of Publications by Year in descending order

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54 papers

1,901 citations

279798 23 h-index 254184 43 g-index

55 all docs

55 docs citations

55 times ranked 2296 citing authors

#	Article	IF	CITATIONS
1	Electrochemical sensing: A prognostic tool in the fight against COVID-19. TrAC - Trends in Analytical Chemistry, 2021, 136, 116198.	11.4	40
2	Thermoelectric generation via tellurene for wearable applications: recent advances, research challenges, and future perspectives. Materials Today Energy, 2021, 20, 100625.	4.7	23
3	Nonenzymatic electrochemical sensors via Cu native oxides (CuNOx) for sweat glucose monitoring. Sensing and Bio-Sensing Research, 2021, 34, 100453.	4.2	15
4	Glutamate sensing in biofluids: recent advances and research challenges of electrochemical sensors. Analyst, The, 2020, 145, 321-347.	3.5	63
5	Fabrication of highly sensitive Bisphenol A electrochemical sensor amplified with chemically modified multiwall carbon nanotubes and β-cyclodextrin. Sensors and Actuators B: Chemical, 2020, 320, 128319.	7.8	74
6	Electrochemical Sensing of Cannabinoids in Biofluids: A Noninvasive Tool for Drug Detection. ACS Sensors, 2020, 5, 620-636.	7.8	50
7	Electrochemical sensing of lead in drinking water using \hat{l}^2 -cyclodextrin-modified MWCNTs. Sensors and Actuators B: Chemical, 2019, 296, 126632.	7.8	49
8	Sweat Glucose Sensing by Directly Bonded Thin Films. , 2019, , .		О
9	Integration of Two-Dimensional Materials: Recent Advances and Challenges. , 2019, , .		1
10	Polymers and organic materials-based pH sensors for healthcare applications. Progress in Materials Science, 2018, 96, 174-216.	32.8	122
11	Copper and liquid crystal polymer bonding towards lead sensing. Japanese Journal of Applied Physics, 2018, 57, 02BB03.	1.5	6
12	Direct bonding of copper and liquid crystal polymer. Materials Letters, 2018, 212, 214-217.	2.6	11
13	Electrochemical sensing of acetaminophen using multi-walled carbon nanotube and \hat{l}^2 -cyclodextrin. Sensors and Actuators B: Chemical, 2018, 254, 896-909.	7.8	154
14	Integrated water quality monitoring system with pH, free chlorine, and temperature sensors. Sensors and Actuators B: Chemical, 2018, 255, 781-790.	7.8	72
15	Tailoring MWCNTs and \hat{I}^2 -Cyclodextrin for Sensitive Detection of Acetaminophen and Estrogen. ACS Applied Materials & Detection of Acetaminophen and Estrogen. ACS Applied Materials & Detection of Acetaminophen and Estrogen. ACS Applied Materials & Detection of Acetaminophen and Estrogen. ACS	8.0	66
16	Integration of Heterogeneous Materials for Wearable Sensors. Polymers, 2018, 10, 60.	4.5	18
17	Morphology and electrical properties of inkjet-printed palladium/palladium oxide. Journal of Materials Chemistry C, 2017, 5, 1893-1902.	5.5	7
18	Bonding mechanism and electrochemical impedance of directly bonded liquid crystal polymer and copper. , 2017, , .		2

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19	Nanocrystalline diamond films prepared by pulsed electron beam ablation on different substrates. Journal of Materials Research, 2016, 31, 1964-1971.	2.6	1
20	Inkjet-printed bifunctional carbon nanotubes for pH sensing. Materials Letters, 2016, 176, 68-70.	2.6	58
21	Paper-Based, Hand-Drawn Free Chlorine Sensor with Poly(3,4-ethylenedioxythiophene):Poly(styrenesulfonate). Analytical Chemistry, 2016, 88, 10384-10389.	6.5	25
22	Low-temperature solution processing of palladium/palladium oxide films and their pH sensing performance. Talanta, 2016, 146, 517-524.	5 . 5	23
23	Inkjet Printing of a Highly Loaded Palladium Ink for Integrated, Lowâ€Cost pH Sensors. Advanced Functional Materials, 2016, 26, 4923-4933.	14.9	76
24	Low-Temperature Bonding for Silicon-Based Micro-Optical Systems. Photonics, 2015, 2, 1164-1201.	2.0	12
25	Nanobonding: A key technology for emerging applications in health and environmental sciences. Japanese Journal of Applied Physics, 2015, 54, 030201.	1.5	8
26	Materials analyses and electrochemical impedance of implantable metal electrodes. Physical Chemistry Chemical Physics, 2015, 17, 10135-10145.	2.8	22
27	Microfabricated electrochemical pH and free chlorine sensors for water quality monitoring: recent advances and research challenges. RSC Advances, 2015, 5, 69086-69109.	3.6	144
28	Future nano- and micro-systems using nanobonding technologies. , 2014, , .		1
29	Nanobonding - A key technology for emerging applications in health and environmental sciences. , 2014, , .		0
30	Polymer integration for packaging of implantable sensors. Sensors and Actuators B: Chemical, 2014, 202, 758-778.	7.8	136
31	Formation of gallium arsenide nanostructures in Pyrex glass. Nanotechnology, 2013, 24, 315301.	2.6	9
32	Charge transfer and stability of implantable electrodes on flexible substrate. Sensors and Actuators B: Chemical, 2013, 178, 132-139.	7.8	24
33	Oxygen Plasma and Humidity Dependent Surface Analysis of Silicon, Silicon Dioxide and Glass for Direct Wafer Bonding. ECS Journal of Solid State Science and Technology, 2013, 2, P515-P523.	1.8	109
34	Low temperature nanointegration for emerging biomedical applications. Microelectronics Reliability, 2012, 52, 361-374.	1.7	7
35	Annealing Temperature-Dependent Interfacial Behavior of Sequentially Plasma-Activated Silicon Bonded Wafers. Journal of Microelectromechanical Systems, 2011, 20, 17-20.	2.5	10
36	Influence of nitrogen microwave radicals on sequential plasma activated bonding. Materials Letters, 2010, 64, 445-448.	2.6	18

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37	Hybrid plasma bonding of germanium and glass wafers at low temperature. Materials Letters, 2010, 64, 1532-1535.	2.6	15
38	Void-free strong bonding of surface activated silicon wafers from room temperature to annealing at $600 \hat{A}^{\circ}$ C. Thin Solid Films, 2010, 519, 804-808.	1.8	36
39	Investigation of bonding strength and sealing behavior of aluminum/stainless steel bonded at room temperature. Vacuum, 2010, 84, 1334-1340.	3.5	27
40	Surface and Interface Characterization of Sequentially Plasma Activated Silicon, Silicon dioxide and Germanium Wafers for Low Temperature Bonding Applications. ECS Transactions, 2010, 33, 329-338.	0.5	17
41	Comprehensive investigation of sequential plasma activated Si/Si bonded interfaces for nano-integration on the wafer scale. Nanotechnology, 2010, 21, 134011.	2.6	28
42	Hybrid plasma bonding for void-free strong bonded interface of silicon/glass at 200°C. Talanta, 2010, 82, 508-515.	5.5	33
43	Annealed proton-exchanged LiNbO 3 ridge waveguide for photonics application. , 2010, , .		2
44	Sequential Plasma-Activated Bonding Mechanism of Silicon/Silicon Wafers. Journal of Microelectromechanical Systems, 2010, 19, 840-848.	2.5	16
45	Role of Heating on Plasma-Activated Silicon Wafers Bonding. Journal of the Electrochemical Society, 2009, 156, H846.	2.9	25
46	Surface-Activated Bonding of Aluminum/Stainless Steel and Its Seal Characteristics. Journal of the Japan Society for Technology of Plasticity, 2006, 47, 596-600.	0.3	0
47	Room temperature wafer level glass/glass bonding. Sensors and Actuators A: Physical, 2006, 127, 31-36.	4.1	70
48	Wafer Level Surface Activated Bonding Tool for MEMS Packaging. Journal of the Electrochemical Society, 2004, 151, G461.	2.9	67
49	Electrical conductivity of Wesgo AL995 alumina under fast electron irradiation in a high voltage electron microscope. Journal of Applied Physics, 2002, 92, 1995-1999.	2.5	13
50	Characterization of the bonding strength and interface current of p-Si/n-InP wafers bonded by surface activated bonding method at room temperature. Journal of Applied Physics, 2002, 91, 3062-3066.	2.5	48
51	Role of specimen thickness on the electrical conductivity of single crystalline alumina under electron irradiation. Journal of Applied Physics, 2001, 89, 1612.	2.5	3
52	In situ measurement of electrical conductivity of Zircaloy oxides and their formation mechanism under electron irradiation. Journal of Nuclear Materials, 1999, 265, 100-107.	2.7	8
53	The electrical conductivity of zircaloy oxide films. Journal of Nuclear Materials, 1998, 253, 149-155.	2.7	18
54	In situ measurement of electrical conductivity of alumina under electron irradiation in a high voltage electron microscope. Journal of Nuclear Materials, 1996, 239, 245-252.	2.7	17